

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79007

Koichi KAWAMURA, et al.

Appln. No.: 10/735,769

Group Art Unit: 1795

Confirmation No.: 3973

Examiner: Daborah Chacko DAVIS

Filed: December 16, 2003

For: PATTERN FORMING METHOD AND SUBSTANCE ADHERENCE PATTERN
MATERIAL

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 8, 2007, please amend the above-
identified application as follows on the accompanying pages.

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